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## Charge collection characterization of irradiated diode using a novel edge-on electron beam technique

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The charge collection of two  $n^+p^+p^+$  pad diodes has been measured using a 5 GeV electron beam (at DESY) entering from the 150  $\mu$ m thick side edge side of diodes. Using the EUDAQ telescope it is possible to precisely reconstruct the beam position. The collected charge as a function of the beam position along the diode thickness is investigated.

This measurement technology is novel and comparable to the better-known edge-TCT. The alignment of the beam direction with respect to the diode surface was done online during the data taking.

The diodes have an area of 25 mm<sup>2</sup> and a p-doping concentration of  $4 \times 10^{12}$  cm<sup>-3</sup>. The measurements were performed at -20 °C for bias voltages up to  $V_{\text{bias}} = 800$  V. One diode was irradiated with 23 MeV protons to a 1 MeV neutron equivalent fluence of  $\Phi_{\text{eq}} = 2 \times 10^{15}$  cm<sup>-2</sup>. The second diode was not irradiated. For the non-irradiated diode, the charge profile is uniform as a function of the beam position. For the irradiated diode, the charge profile is non-uniform and the changes as the applied bias voltage.

This work presents the procedure of measurement and the online alignment along with the results obtained for two diodes.

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